## DEPARTMENT OF ELECTRICAL AND ELECTRONICS ENGINEERING \& INTERDISCIPLINARY NANO RESEARCH CENTRE

## PRESENTS

## EXCLUSIVELY <br> FOR RESEARCH SCHOLARS AND SVCE FACULTIES

## WORKSHOP ON <br> IC FABRICATION

## RESOURCE PERSON

Peter Lee, Manager, Midas System Co Ltd Republic of Korea

## CHIEF PATRON

Prof. M. Sivanandham, Secretary, SVCE

## PATRON

Prof. S. Ganesh Vaidyanathan, Principal, SVCE

## CONVENOR

Dr.KR.Santha, Vice-Principal, Professor \& Head of Dept, Department of EEE

# Sri Venkateswara College of Engineering Pennalur, Sriperumbudur 602117 

## Interdisciplinary Nano Research Centre

Three days workshop on IC Fabrication : November $7^{\text {th }} \mathbf{- 9}^{\text {th }}, \mathbf{2 0 2 1}$

## Workshop Report

Department of Science and Technology (DST) FIST sponsored Interdisciplinary Nano Research Centre (iNRC), Sri Venkateswara College of Engineering, houses a1000 Sq.ft non-conventional Class-10,000 clean-room facility with state-of-the-art sophisticated nano-fabrication and characterization facilities, which provides end to end support from IC design, Nano-device modeling, fabrication and characterization.

A new state-of-the-art MDA-400LJ Mask Aligner and exposure system was procured from Midas System Co. Ltd, South Korea. Mr.Peter Lee, Manager, Midas Systems, and Mr.Rahul Chaudhary, Director, Aura Innovative Technologies, New Delhi, visited SVCE from $06^{\text {th }}$ to $09^{\text {th }}$ of November 2021 and trained a team of faculty members at SVCE headed by Dr.Sudhakar.KB, Prof/EEE on IC Fabrication and the process of Photolithography. The laboratory which specializes on thin film technology has now developed into a fully functional Nano device fabrication facility, with the installation of Photolithography- Mask Aligner and Exposure System. This facilitates SVCE to design and fabricate a complete IC chip and various other optoelectronic devices.

Fields of Application: Micro- and Nano-electronics, MEMS, Nanobiotechnology, Biomedical devices, Wearable devices, Smart Materials, Solar and sustainable energy.

## Summary of Events:

| Nov $6^{\text {th }} 2021$ | Start of installation: Opening of the Mask aligner System and checking all <br> the components and modules. |
| :--- | :--- |
| Nov $7^{\text {th }} 2021$ | 1. Hands-on demonstration of the mask aligner and exposure system. <br> 2. Photolithography process - Patterning, Etching and Developing. <br> 3. Alignment process - Multi step lithography with alignment. |
| Nov $8^{\text {th }} 2021$ | Hands-on training of the above process by the SVCE faculty members. |
| Nov $9^{\text {th }} 2021$ | $\underline{\text { Interactive session - Experts and participants. }}$ |



KR.Sarl-

Participants List:

|  | Title | Name | Designation | Department |
| :---: | :--- | :--- | :--- | :--- |
| S.No | Ms | ANITHA S | Assistant Professor | EEE |
| 1 | Ms | Assistant Professor | EEE |  |
| 2 | Mrs | SASIKALA M | Assistant Professor | EEE |
| 3 | Mrs | SINTHAMANI S | Assistant Professor | EEE |
| 4 | Mr | S.SUDHARSANAM | Assistant Professor | EEE |
| 5 | Mrs | M.RANJITHKUMAR | Assistant Professor | EEE |
| 6 | Mr | VINOTH KUMAR G |  |  |

KR.Sarl

Sri Venkateswara

## Department of Electrical and Electronics Engineering INTERDISCIPLINARY NANO RESEARCH CENTRE Certificate of Participation

This is to certify that
S. Anitha of

## SRI VENKATESWARA COLLEGE OF ENGINEERING

has participated in the International workshop on IC FABRICATION organized by the Department of Electrical and Electronics Engineering in association with Midas systems, Korea on $7^{\text {th }}-9^{\text {th }}$ July 2021.
|chg. Lschlid

Dr. Sudhakar K Bharatan
Prof/EEE
Event Coordinator


Top Ranked Affiliated Institution in Tamil Nadu


5/5 Star Rated Innovation Cell
 Performer

## KR. Sail

Dr. KR. Santha
Vice Principal, Prof \& Head / EEE


Certified Organization


Accreditation

